

Notice of References Cited

Application/Control No.

09/779,115

Applicant(s)/Patent Under

Reexamination

VAN DER KOLK ET AL.

Examiner

Archene Turner

Art Unit

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-US005928771A	07-1999	DeWald JR et al	428
	B	US-4731302	03-1988	Weissmantel et al	428
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	0 179 582	04-1986	EP	Energy Conversion	--
	O	2179678	03-1987	GB	UK Atomic	--
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Onate et al "Deposition of hydrogenated B-C thin films and their mechanical and chemical characterization" Surface & Coating Technology, 49 (199) 548-553.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
 Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.